Attorney's Docket No.: 03351-009005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Michael E. Fossey et al. Art Unit: Unknown Serial No.: New Continuation Application Examiner: Unknown

Filed : June 24, 2003

Title : WAFER INSPECTION SYSTEM FOR DISTINGUISHING PITS AND

PARTICLES

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Under 35 USC §120, this application relies on the earlier filing dates of application serial number 10/301,677, filed on November 22, 2002, 09/906,062, filed on July 17, 2001, serial number 09/624,502, filed July 24, 2000, serial number 08/958,230, filed October 27, 1997, and serial number 08/399,962, filed March 6, 1995. The attached list of references were submitted to and/or cited by the Office in the prior applications and, therefore, are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: June 24, 2003

John F. Hayden Reg. No. 37,640

Fish & Richardson P.C. 1425 K Street, N.W. 11th Floor

Washington, DC 20005-3500 Telephone: (202) 783-5070 Facsimile: (202) 783-2331

information disclosure statement.doc

Substitute	Form	PTO-	1449
(Modified)			

U.S. Department of Commerce Patent and Trademark Office Attorney's Docket No. 03351-009005

Application No.
Continuation Application

Information Disclosure Statement

by Applicant

(Use several sheets if necessary)

Michael E. Fossey et al.

Filing Date

Applicant

Group Art Unit

(37 CFR §1.98(b))

June 24, 2003

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	AB	3,904,293	09/1975	Gee			
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Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Substitute Form PTO-1449 (Modified)

U.S. Department of Commerce Patent and Trademark Office

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(37 CFR §1.98(b))

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(Use several she	eets if necessary)	Filing Date Tune 24, 2003	Group Art Unit	

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	AEEE	61-240663	10/1986	Japan				
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١	(37 CFR §1.98(b))		June 24, 2003		

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Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
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	АНННН	Dissertation at Arizona State University, pp. 1-281
	AIIII	Starr et al., "Comparison of Experimentally Measured Differential Scattering Cross Sections of PSL Spheres on Flat Surfaces and patterned Surfaces," SPIE vol. 2862, (Sep. 1996) pp. 130-138
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	AXXXX	Stover et al., "Some Deviations Associated with Vector Pertubation Diffraction Theory," SPIE vol. 511 (1984) pp. 12-17

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	AZZZZ	Nee, "Reflection, Scattering, and Polarization from a Very Rough Black Surface," SPIE vol. 1995		
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